



In re Application of

FAI ET AL

Serial No. 09-888,494

Filed: June 26, 2001

For METHOD FOR FORMING A METAL OXIDE SEMICONDUCTOR TYPE FIELD EFFECT TRANSISTOR

BOX AF

THE COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, D. C. 20231

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

[X] No additional fee is required.

[] Also attached:

The fee has been calculated as shown below:

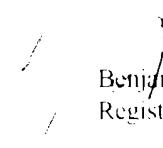
	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	Fee
Total Claims	18	20	0	x \$18	
Independent Claims	2	3	0	x \$84	
If multiple claims newly presented, add \$280.00					
Fee for extension of time					
TOTAL FEE DUE					-00-

[] A check in the amount of \$ is attached.

[X] The Commissioner is hereby authorized to charge payment of any additional fees associated with this communication or credit any overpayment, to Deposit Account No. 07-1337, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

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